

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
)	Group Art Unit: 2892
Shinji Omori)	
)	Examiner: Phuc T. Dang
Application No. 10/534,917)	
)	
Filed: September 26, 2005)	
)	
For: EXPOSURE DEVICE, EXPOSURE)	
METHOD, AND SEMICONDUCTOR)	
DEVICE MANUFACTURING METHOD)	
)	

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Dear Sir:

This amendment is being filed in response to the Office communication dated January 30, 2008. Please reconsider the application in view of the amendment and remarks presented below.

ELECTION OF CLAIMS

In response to the restriction requirement, applicant elects Group I, claims 1 - 14 for further examination.

Applicant reserves the right to file divisional applications covering the subject matter of the non-elected claims and/or to request rejoinder of non-elected claims.

Respectfully submitted,

Dated: February 26, 2008

By: /David R. Metzger/, Reg. 32,919
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